EAST Search History

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Ref #	Hits	Search Query	DBs	Default Operat or	Plural s	Time Stamp
L17	231	239/464 CCLS.	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/30 03:33

EAST Search History

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Ref #	Hits	Search Query	DBs	Default Operat or	Plural s	Time Stamp
L1	893	(239/472.CCLS. OR 239/487.CCLS. OR 239/488.CCLS.)	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/30 02:23
L2	167	(239/472.CCLS. OR 239/487.CCLS. OR 239/488.CCLS.) AND (WASH\$4 OR CLEAN\$4 OR "134"/\$.CCLS.)	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/30 02:25
L5	291	(239/472.CCLS. OR 239/487.CCLS. OR 239/488.CCLS.) AND (VORTEX\$4 OR HELICAL\$4 OR SPIRAL\$4)	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/30 02:32
L11	122	"134"/\$.CCLS. AND ((VORTEX\$4 OR HELICAL\$4 OR SPIRAL\$4 OR SWIRL\$4 OR TORNADO OR WHIRL\$4) NEAR6 (PATTERN OR STREAM OR SPRAY OR SHAPE) NEAR6 (NOZZLE OR JET OR SHOWER OR SPRAYER))	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/30 02:57



United States Patent [19]

Yoshitani et al.

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Patent Number:

5,975,098

Date of Patent: [45]

Nov. 2, 1999

	APPARATUS FOR AND METHOD OF CLEANING SUBSTRATE				
[75] I	Nitsuaki Yoshitani; Kazuo Kinose; Satoru Tanaka; Kenya Morinishi; Masahiro Miyagi, all of Shiga; Naoshige Itami; Kazuhiro Watanabe, both of Kanagawa, all of Japan				
[73]	ssignees: Dainippon Screen Mfg. Co., Ltd., Fujitsu Limited, both of Japan				
[21]	.ppl. No.: 08/775,712				
[22] I	iled: Dec. 17, 1996				
[30]	Foreign Application Priority Data				
	, 1995 [JP] Japan				
[51] I	nt. Cl. ⁶ B08B 3/02				
[52] U	.S. Cl				
[58] I	ield of Search				
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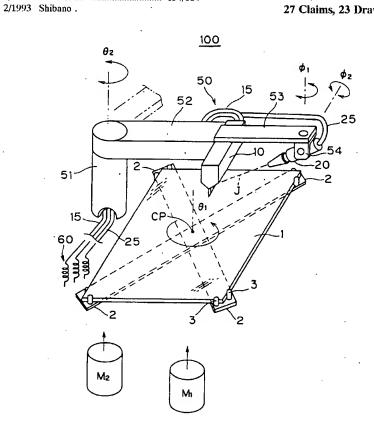
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Primary Examiner-Frankie L. Stinson Attorney, Agent, or Firm-Ostrolenk, Faber, Gerb & Soffen, LLP

[57] **ABSTRACT**

A substrate rinsing apparatus of a non-contact type having a high rinsing ability. An ultrasonic rinsing nozzle and a high-pressure rinsing nozzle are both disposed within the same rinsing apparatus. The ultrasonic rinsing nozzle ejects ultrasonic rinsing liquid as a curtain through a slit, while the high-pressure rinsing nozzle ejects a high-pressure rinsing jet toward the ultrasonic rinsing liquid which is ejected toward a substrate. Not only is foreign matter removed by ultrasonic rinsing, but foregoing matter is removed by the high-pressure rinsing jet and is carried away by a flow of the ultrasonic rinsing liquid and washed off the substrate toward a downstream side of rotation of the substrate.

27 Claims, 23 Drawing Sheets



EAST Search History

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L13	832	134/123.CCLS.	US-PGPU B; USPAT; USOCR; FPRS; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/30 03:15
L14	1316	134/198.CCLS.	US-PGPU B; USPAT; USOCR; FPRS; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/30 03:15
L16	45	((CAR OR VEHICLE OR TRUCK OR AUTO OR AUTOMOBILE) NEAR5 (WASHING OR WASH OR CLEAN\$4)) AND ((VORTEX\$4 OR HELICAL\$4 OR SPIRAL\$4 OR SWIRL\$4 OR TORNADO) NEAR6 (PATTERN OR STREAM OR SPRAY OR SHAPE) NEAR6 (NOZZLE OR JET OR SHOWER OR SPRAYER))	US-PGPU B; USPAT; USOCR; EPO; JPO; DERWEN T; IBM_TDB	OR	ON	2007/04/30 03:23